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DOCKET NO.: 245469US2DIV/ims



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF:

Tadashi IGUCHI, et al.

SERIAL NO: 10/716,556

GROUP: 2813

FILED: November 20, 2003

EXAMINER: CHEN, JACK S. J.

FOR: NONVOLATILE SEMICONDUCTOR MEMORY DEVICE AND ITS
MANUFACTURING METHOD

LETTER

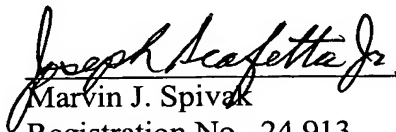
Mail Stop DD
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Submitted herewith is a PEOPLE'S REPUBLIC OF CHINA Office Action for the Examiner's consideration. The reference cited therein, JP 11-163304 has been previously filed on November 20, 2003, however we are filing herewith a copy of its English Abstract.

Respectfully Submitted,

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